

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Jiutao Li et al.

Application No.: 10/712,106

Confirmation No.: 8216

Filed: November 14, 2003

Art Unit: 1753

For: SILVER SELENIDE SPUTTERED FILMS  
AND METHOD AND APPARATUS FOR  
CONTROLLING DEFECT FORMATION IN  
SILVER SELENIDE SPUTTERED FILMS

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Examiner: R. G. McDonald

**RESPONSE TO FINAL ACTION**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Madam:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated June 3, 2009, finally rejecting claims 1-84, please consider the following remarks:

**A listing of the Claims** begins on page 2 of this paper.

**Remarks** begin on page 15 of this paper.